

6th EUV-FEL Workshop



Contribution ID: 7

Type: **not specified**

Invited speaker (4) Demonstration of Proof-of-Concept of EUV and Beyond EUV FELs for Future Lithography

Tuesday, 18 January 2022 16:20 (30 minutes)

Presenter: NORIO NAKAMURA (KEK) (KEK)